

**Notice of References Cited**

Application/Control No.

10/532,952

Applicant(s)/Patent Under  
Reexamination  
ANEGAWA ET AL.

Examiner

JEONG S. PARK

Art Unit

2454

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,807,388	10-2004	Kojima et al.	399/80
*	B	US-2003/0107771	06-2003	Shibata, Koichi	358/3.28
*	C	US-2003/0154395	08-2003	Miura et al.	713/200
	D	US-			
	E	US-			
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	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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